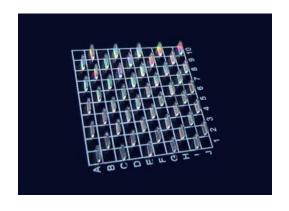


Mgo:PPLN Crystals Chips for 532nm Laser Generation

without OC Mirrors

- High power and high efficiency
- Small size, no mirrors needed

The MgO doped periodically poled lithium niobate chips (or **PPLN crystals**) for 532nm laser generation with high-power up to 4 watts are offered in Hangzhou Shalom EO, the output facet is coated with HR@1064nm and HT@532nm, it makes the OC mirrors unnecessary for your lasers, which may reduce the cost and the size of your laser system.





SPECIFICATIONS

Optical Specification		
Length	1.0~2.0mm	
Width	~ 2.0mm	
Thickness	0.5mm	
Coating on Input facet	AR@1064nm + AR @532nm	
Coating on Output facet	HR@1064nm + HT@532nm (without output mirror)	
Optical to Optical Efficiency (intra-cavity)	³ 30%	
Operation Temperature	~ 33° C	
Temperature Tolerance	> 25 °C	

Note: The PPLN crystals with the Copper heat-sink packing is available.



Polishing Specifications		
Tolerance of Size	(Width±0.1mm) x(Thickness±0.05mm) X (Length±0.1mm)	
Flatness	< Lambda/8 @ 633nm	
Wavefront Distortion	< Lambda/6 @ 633nm	
Chips	<0.1mm	
Surface Quality	20/10 S/D	
Parallelism	<10"	
Perpendicularity	<10′	

Basic Properties

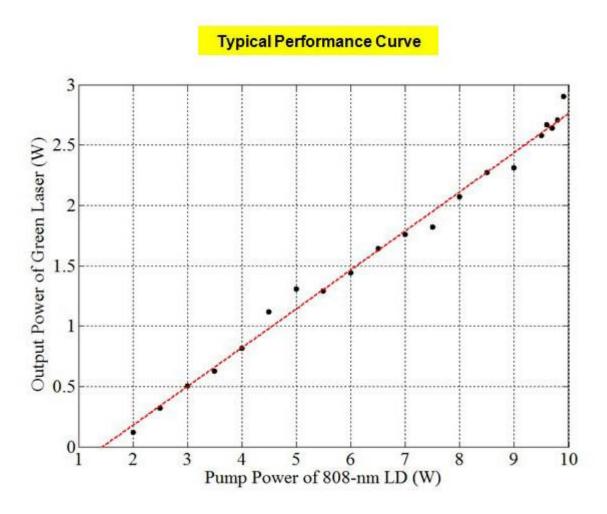
Chemical and Physical Properties		
Melting Point	1255+/-5 °C	
Curie Point/Temperature	1140+/-5 °C	
Mohs Hardness	5	
Density	4.648(5)g/cm3	
Thermal conductivity	38W/m/K @ 25 °C	
Coefficient of thermal expansion	//a, 2.0x10-6/K	
	//c, 2.2x10-6/K	

Optical and Nonlinear properties		
Wavelength range of Transmission	420nm ~ 5200nm	
Nonlinear coefficient	d33 = 34.4 pm/V	
	d31 = d15 = 5.95 pm/V	
	d22 = 3.07 pm/V	
Optical Damaging Threshold	0.3GW/cm2	
Absorptive Coefficient	0.004/cm @ 1064nm	



Application Notes

Typical Performance Curve



Typical Configurations for PPLN chips without OCMirror

